



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/798,653
Applicant: Edmond BAILLOT, et al.
Filed: March 11, 2004
Title: Plasma cutting process with dual gas flow
TC/A.U. 3742
Examiner: Unknown
Docket No.: Serie 6150
Customer No.: 000040582

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents
P.O. Box 1450
Washington, D.C. 20231


Dear Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited on the enclosed PTO Form 1449 is enclosed.

No fee is due at this time in accordance with 37 C.F.R. § 1.97. However, the Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 01-1375. This paper is submitted in duplicate.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

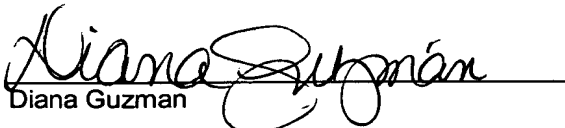

Elwood Haynes, Reg. No. 55,254

Date: June 17, 2004

Air Liquide
Intellectual Property Department
2700 Post Oak Boulevard, Suite 1800
Houston, Texas 77056
(713) 624-8956 Phone – (713) 624-8950 Fax

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 17th day of June, 2004.


Diana Guzman

